

Corres. and Mail

PATENT APPLICATION

D. Nguyen

RESPONSE UNDER 37 CFR §1.116 EXPEDITED PROCEDURE **TECHNOLOGY CENTER ART UNIT 2828**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Daniel KOPF et al.

Application No.: 10/006,396

Filed: December 10, 2001

Examiner:

Docket No.: 111399

Group Art Unit: 2828

HIGH POWER AND HIGH GAIN SATURATION DIODE PUMPED LASER MEANS

AND DIODE ARRAY PUMPING DEVICE

AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For:

In reply to the March 10, 2004 Final Rejection, the period for response having been extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.